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TSMC-01-660



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TECHNOLOGY CENTER 2800

To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
Poughkeepsie, NY 12603

Subject: Serial No. 10/083,991 02/26/02
C. CHANG
"PLANARIZATION METHOD FOR DEEP SUB MICRON
SHALLOW TRENCH ISOLATION PROCESS"
Grp. Art Unit: 2812 S. ISAAC

RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated
June 7, 2002 please amend the above identified Application
for Patent as follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner of
Patents and Trademarks, Washington, D.C. 20231 on
September 9, 2002.

✓
Name Stephen B Ackerman Reg #37,761
Signature [Signature]
Date 9/9/02